



35.C15334

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

KAZUYA ISHIWATA ET AL.

Application No.: N.Y.A.

Filed: May 2, 2001

For: ELECTRON SOURCE FORMING
SUBSTRATE, ELECTRON
SOURCE USING THE
SUBSTRATE, AND IMAGE
DISPLAY APPARATUS

Examiner: Not Yet Assigned

Group Art Unit: N.Y.A.

August 23, 2001

Commissioner of Patents
Washington, D.C. 20231

Handwritten: #120, mk, 5/22/03

TECHNOLOGY CENTER 2800

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. A copy of each listed document is also enclosed.

The concise explanation of relevance for the listed Japanese document may be found in its English-language abstract, submitted herewith, and in the specification at page 3, where this reference is cited. The explanation of relevance for the listed Japanese-language article may be found in its counterpart U.S. Patent, submitted herewith, and in the specification at page 2, where this reference is cited.

TECHNOLOGY CENTER 2800

RECEIVED
MAR 10 2003



The Examiner's attention is also directed to the following U.S. Applications:

<u>APPLICATION NO.</u>	<u>FILING DATE</u>	<u>GROUP ART UNIT</u>
09/847,420	05/03/01	NYA
09/845,286	05/01/01	2879

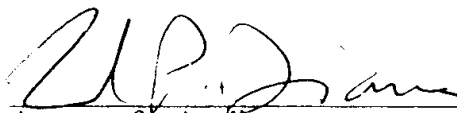
A copy of each cited Application, as originally filed, is enclosed.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,


Attorney for Applicants

Registration No. 79,286

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200

TECHNOLOGY CENTER 2800
MAR 10 2003
TECHNOLOGY CENTER 2800

RECEIVED